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Deep Learning and Machine Learning in Image Processing and Pattern Recognition

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Message from the Guest Editors

Dear Colleagues,

Pattern recognition and image processing have grown in importance within the field of artificial intelligence due to the swift advancement of science and technology. This field has developed rapidly in recent years due to the growing use of machine learning and deep learning in image processing and pattern recognition. The goal of this Special Issue is to examine the most recent developments as well as potential directions for machine learning and deep learning in pattern recognition and image processing.

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Guest Editors

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Message from the Editor-in-Chief

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